

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Kevin J. Orvek et al.	Art Unit :	2823
Patent No. :	7,242,020	Examiner :	Jarrett J. Stark
Issue Date :	July 10, 2007	Conf. No. :	7571
Serial No. :	10/814,883		
Filed :	March 31, 2004		
Title :	REAL-TIME MONITORING OF PARTICLES IN SEMICONDUCTOR VACUUM ENVIRONMENT		

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PETITION TO WITHDRAW

Applicant hereby petitions under §1.313(c)(3) for the withdrawal of this application from issue in favor of two continuing applications. This petition is being filed with an accompanying Express Abandonment of the above-identified application. The issue fee was paid on June 5, 2007. Two continuation applications, namely continuation application serial Nos. 11/773,197 and 11/773,220, claiming priority from the above-identified application, were filed on July 3, 2007. These continuation application are intended to enable applicant to prosecute the inventions claimed in the above-mentioned continuation applications upon the grant of this petition.

Please charge the amount of \$130 to Deposit Account No. 06-1050, referencing the above-identified attorney-docket No., in payment of the petition fee required by 1.17(h). Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date:

July 5, 2007

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